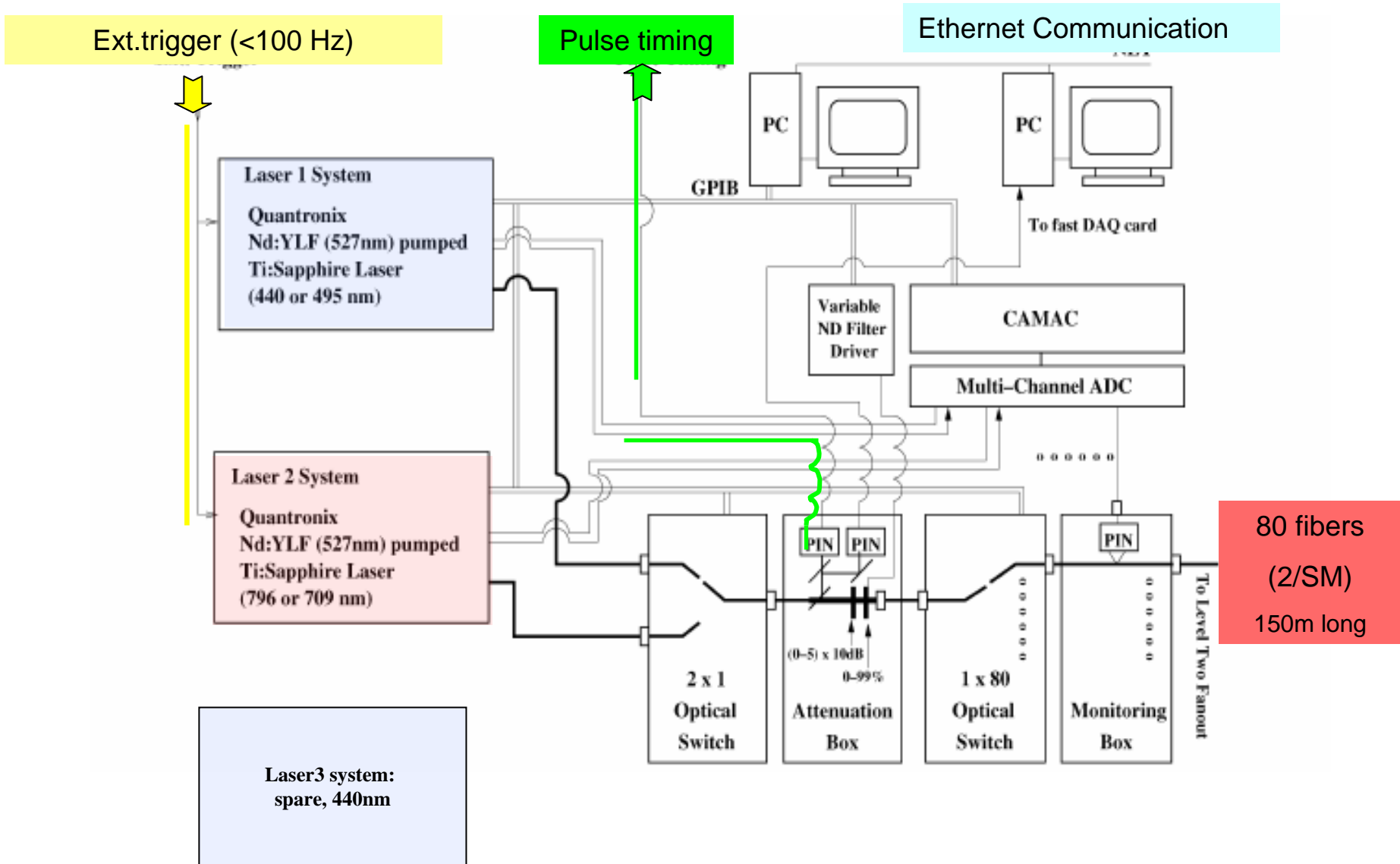




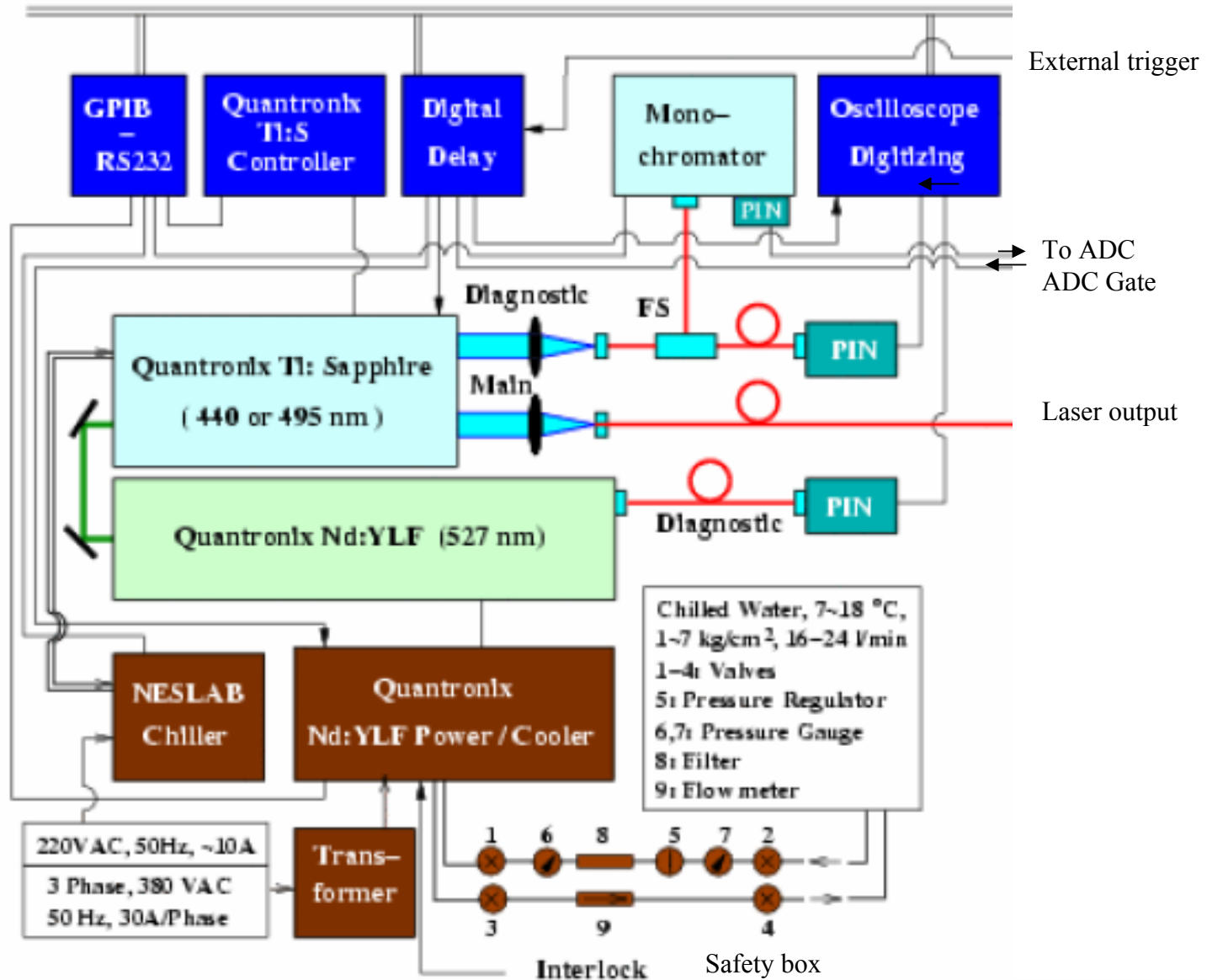
The system is design to continuously monitor the ECAL *in situ* at CMS

# Monitoring Light Source and High Level Distribution

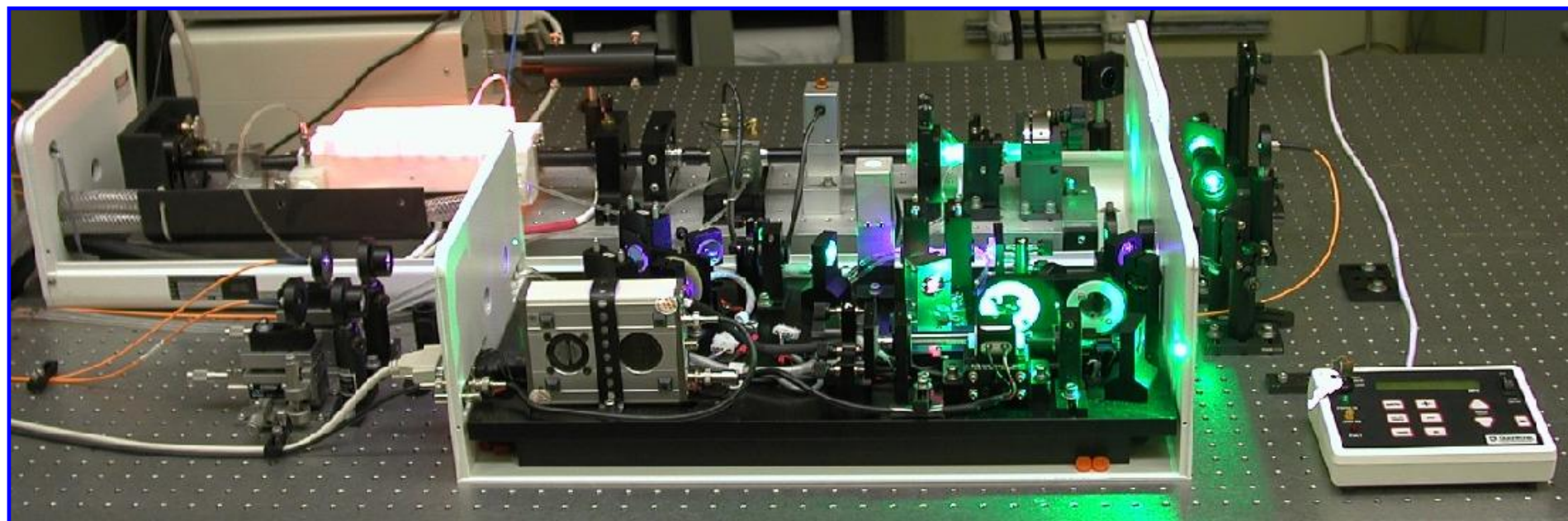
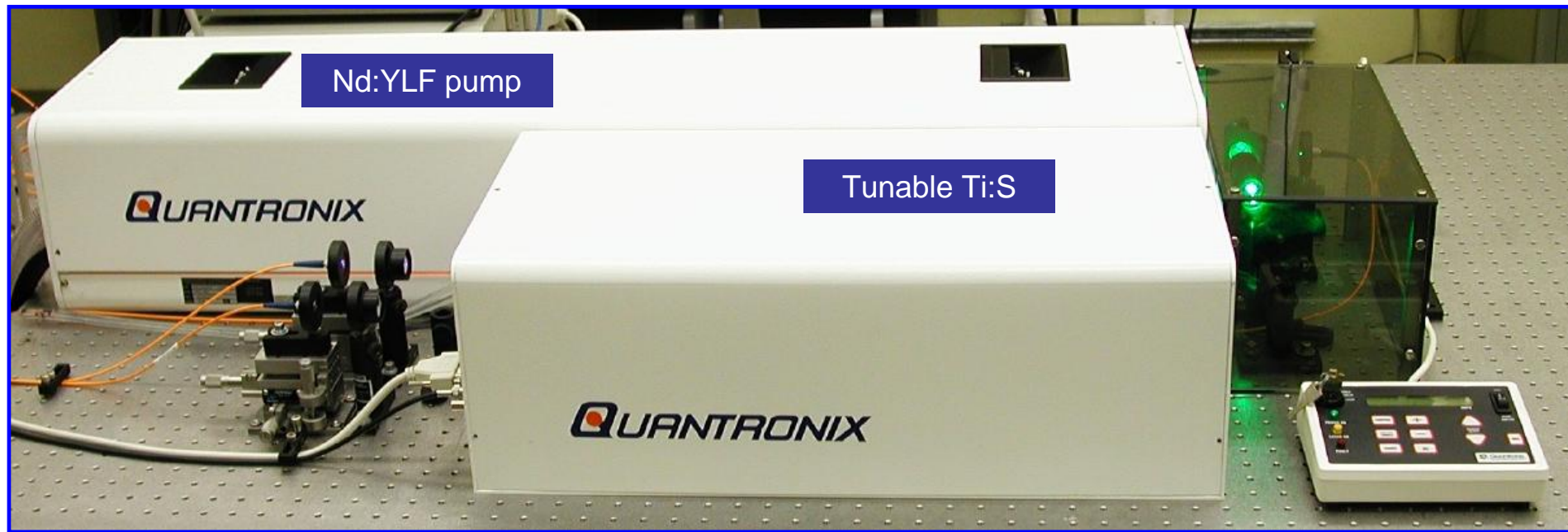


# Details of One Laser System

GPIB









# Laser Specifications & Environment



## Laser specifications :

- ⇒ 2 wavelengths:
  - one close to the emission peak → best monitoring linearity (440 nm)
  - one to monitor readout electronics chain from the APD to the ADC (796 nm)
- ⇒ Pulse Jitters: < 4ns/2ns for long (24 h)/short (0.5 h) term
- Pulse width: < 40ns
- Pulse energy: 1 mJ/pulse (>1TeV equivalent energy deposition in each crystal).
- Pulse rate: <100 Hz
- Intensity instability: < 10%

	YLF*	Ti:S 1		Ti:S 2	
$\lambda$ (nm)	527	440	495	796	709
<b>Pulse energy (mJ)</b>	20	1	0.5	1.5	0.42
<b>Pulse width (ns)</b>	100-170	25-30	40-50	25-30	30

\*YLF = *Yttrium Lithium Fluoride*

- ⇒ Environment:
    - cleanroom class <10,000 :
    - temperature stabilized to  $\pm 0.5$  °C:
    - Humidity <60%:
- done since May 2005 with softwall clean room facility  
to be done in CMS by ALEPH Air-Conditioning Unit  
to be done in CMS by ALEPH Air-Conditioning Unit*



## On-Line System

- Digital scope
- Digital scope
- Camac and modules
- Safety box
- Diagnostic box
- Diagnostic box
- Monitoring box
- Monitoring box
- PC monitor
- 1 x 80 optical switch
- Attenuation box
- 2 x 1 optical switch
- PC
- Digital delay (DG 535)
- Digital delay (DG 535)
- Network
- GP1B - RS232
- GP1B - RS232



## Off-Line System

- Digital scope
- Camac and modules
- Diagnostic box
- PC monitor
- Network
- PC
- GP1B - RS232
- Digital delay (DG 535)

**Input/Output laser barrack:**

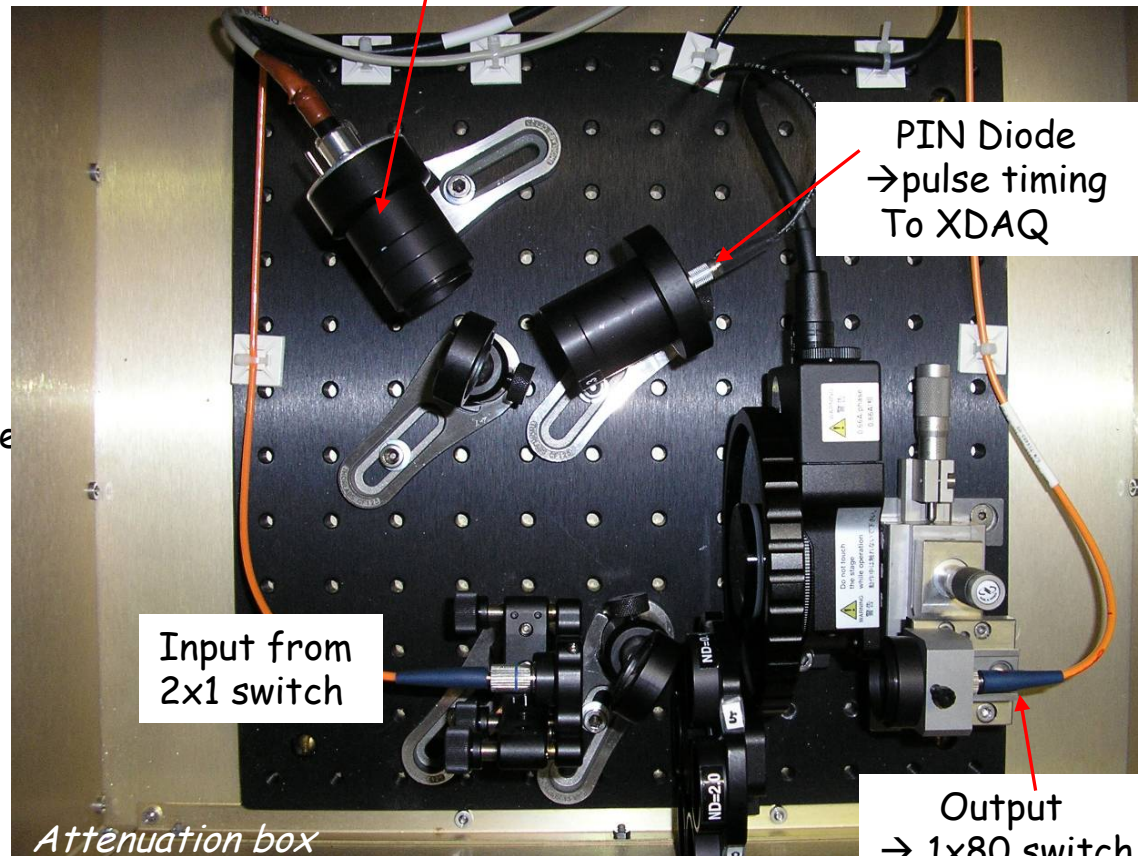
Ethernet communication: **IN/OUT**  
With XDAQ & DIM DNS server

External trigger: **INPUT (XDAQ)**  
Use to generate YLF laser pulse  
< 100 Hz, TTL

Pulse timing: **OUTPUT (XDAQ)**  
Laser pulse digitalized: inform when pulse  
has been sent to SM.  
Before 1x80 switch  
(Before 150m long fibers)

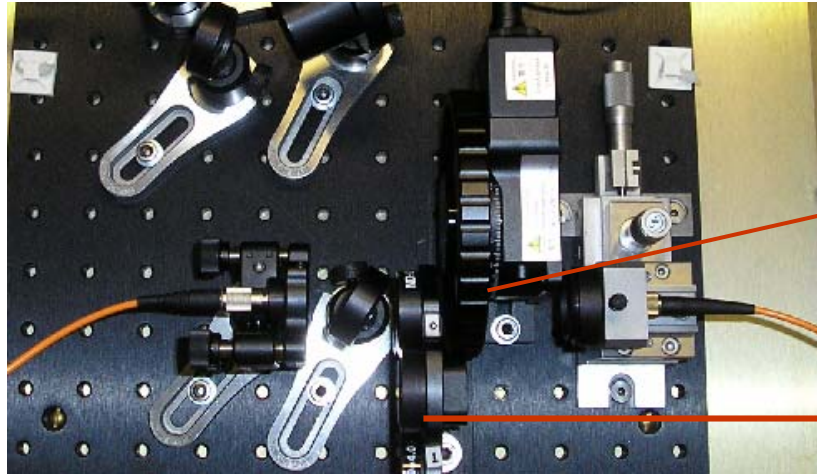
Level 2 TTL for safety: **INPUT**  
from MEM to safety crate, 5V

PIN Diode detector  
→ Pulse to Acqiris DP210 & Matacq





## Attenuation box:



**Variable Reflective Neutral Density Filters**  
Optical Density from 0.04 - 2.7



+

neutral density filters: 0-10-20-30-40-50 dB

Software modification for attenuation mode:

0-100% with Ti:S regulator → variable density filter



0% = max. attenuation (27 dB loss)  
100% = min. attenuation (0.4 dB)



**Laser safety:** → Limited access to the barrack

All the safety is controlled by the safety box:

- **Outer door** : - interlock + flash lamp + 3 LED
- **Inner doors** : - 3 interlocks
  - 3 boxes: Flash LED+ yellow LED
- **Level 2 TTL** from MEM box:
  - low level if the laser pulse does not reach level 2 fanouts (e.g., accidentally broken fiber)
  - high level if the level 2 fanouts receive laser pulse.



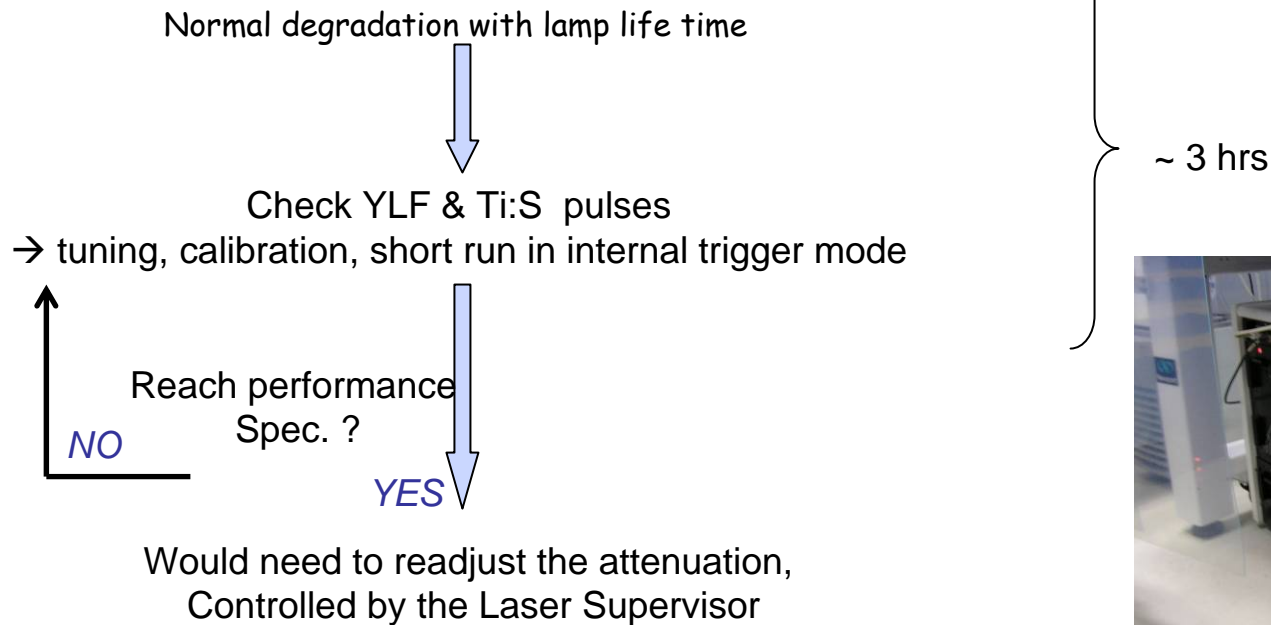
**CLASS 4**



2 modes of operation:

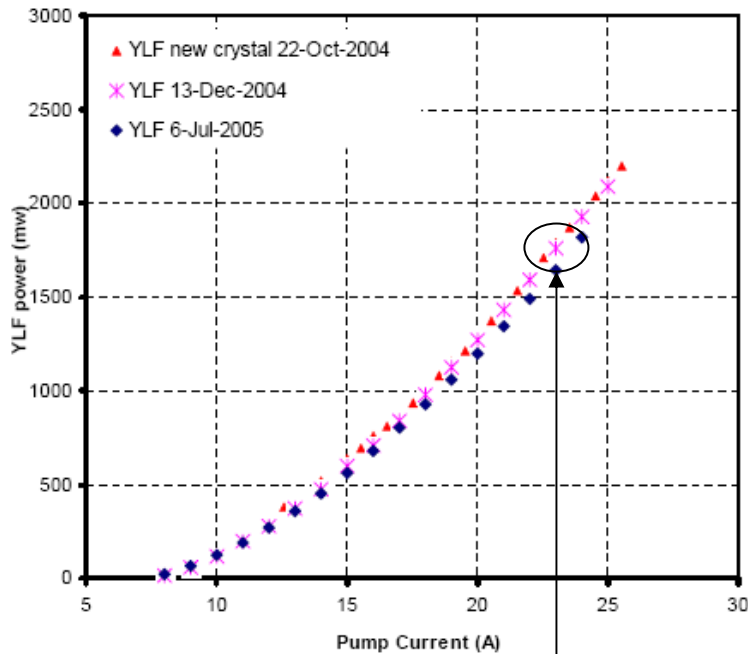
- 1) **Normal operation** : inner doors should be closed and you can enter in the barrack without closed the shutter
- 2) **Maintenance operation**: inner doors can stay opened to work on the laser, then the outer door controls the shutters

- Check the chilled water, change filter if it is too dirty
- Check the internal cooling water level (distilled water)
- Change the deionizing cartridge and the particle filter in the internal cooling unit (90 days)
- Check Neslab water level for Ti:S LBO
- Change **YLF lamp every 500 up to 1000 hrs (20 to 40 days).**



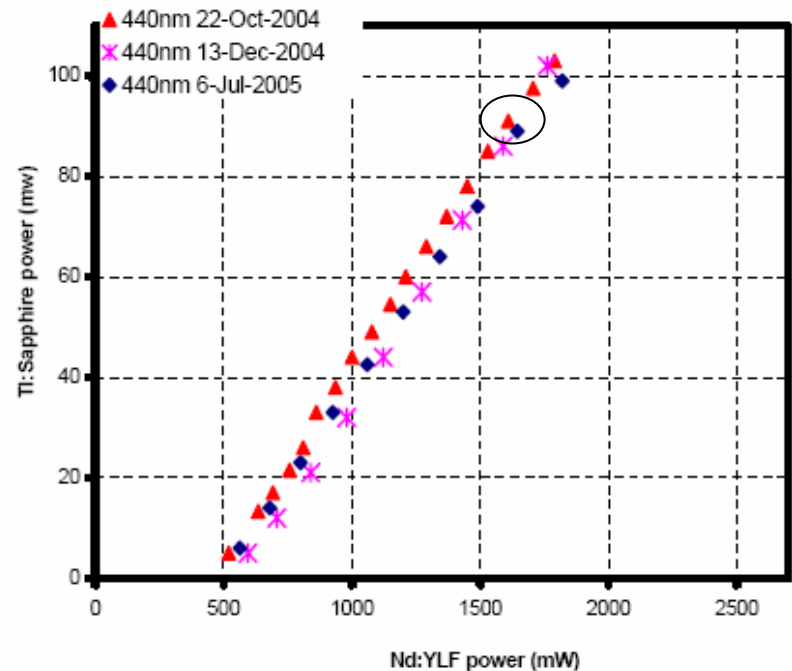
Laser main controls: **YLF:** pump current  
**Ti:S:** pulse delay/YLF pulse:  $\sim 5\text{ns}$  max. (+optics tuning, HV Q-switch)

Nd:YLF LASERS 1



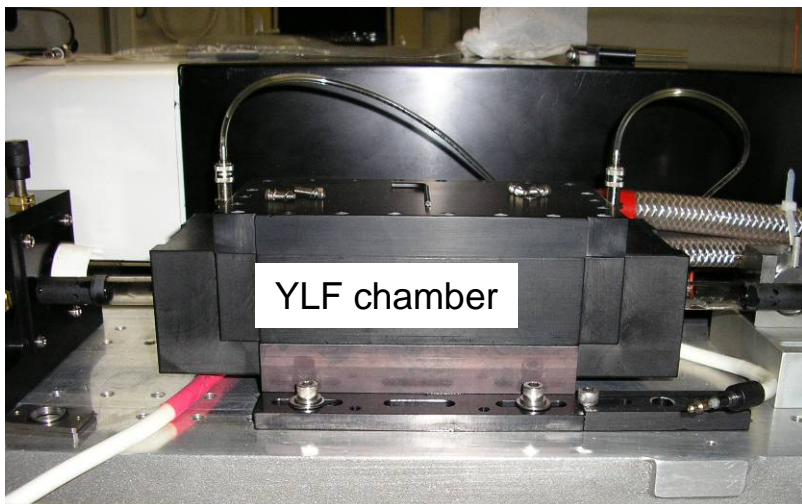
Working point: 23A

Nd:YLF LASER PUMPED TI:S LASERS 1





2004: Optics damage caused by dirty environment and broken flow tubes  
 2005: Broken flow tubes and electronics: mother board of 1x80 switch



Life time:

- lamp: ~500 – 1000 hrs.  
     → Lamp aging: 0.5% daily
- flow tube: 1 year
- gold reflector: to be checked every year



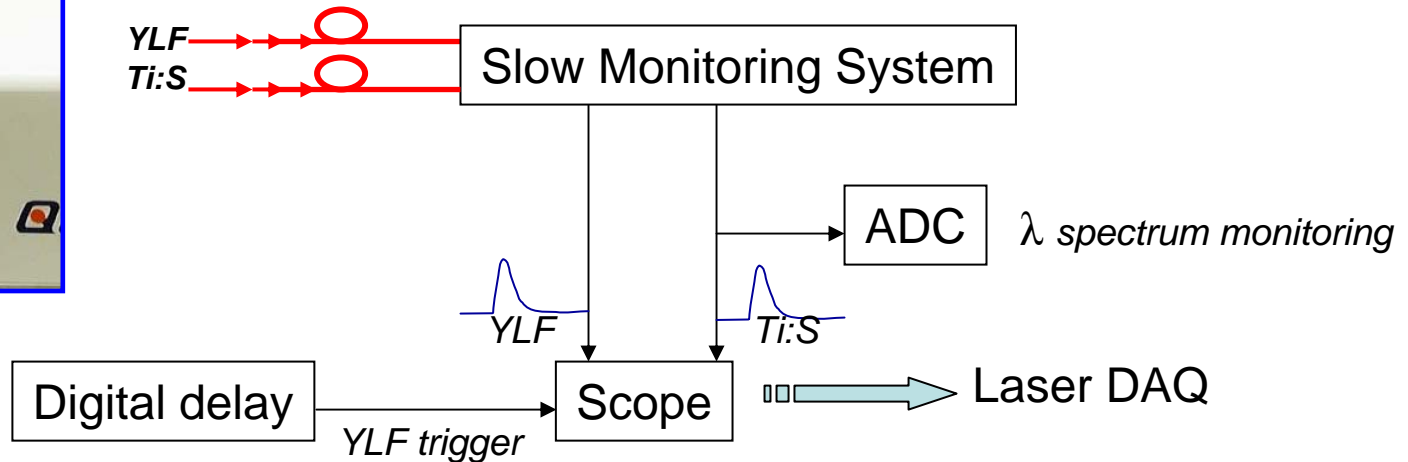
## 3 monitoring systems: SLOW (DSO for each laser system) & 2 FAST (Acqiris DP210 & MATAQQ)

### Slow monitoring

- Control lasers setup,
- Check YLF and Ti:S performance at 1 Hz
- *Keep laser history for diagnostics*



Laser diagnostic output





# Laser DAQ Control Display



## Laser System Control

**Laser Control**

Laser 1 <span>Online</span>			Laser 2 <span>Offline</span>			Monitor	
YLF	Ti:S	DG535	YLF	Ti:S	DG535	View	Hist
Shutter	Shutter	Trigger	Shutter	Shutter	Trigger	<input type="checkbox"/>	<input type="checkbox"/>
<input type="button" value="CLOSE"/>	<input type="button" value="Close"/>	<input type="button" value="Internal"/>	<input type="button" value="CLOSE"/>	<input type="button" value="Close"/>	<input type="button" value="Internal"/>	Mode	Gate (ns)
Lamp	Wavelength	Rep. Rate	Lamp	Wavelength	Rep. Rate	<input type="button" value="SCAN"/>	<input type="text" value="200"/>
<input type="button" value="OFF"/>	<input type="text" value="440"/>	<input type="text" value="100.0"/>	<input type="button" value="OFF"/>	<input type="text" value="440"/>	<input type="text" value="100.0"/>	Channel	Energy
Current	Energy	Delay A	Current	Energy	Delay A	<input type="text" value="1"/>	<input type="text" value="0.00000"/>
<input type="text" value="15.00"/>	<input type="text" value="0.0"/>	<input type="text" value="2.679500"/>	<input type="text" value="15.00"/>	<input type="text" value="0.0"/>	<input type="text" value="2.679500"/>	<input type="button" value="START"/>	
Cooler	Temperature	Delay B	Cooler	Temperature	Delay B	<input type="button" value="Exit"/>	
<input type="button" value="OFF"/>	<input type="text" value="20.00"/>	<input type="text" value="4.612000"/>	<input type="button" value="OFF"/>	<input type="text" value="20.00"/>	<input type="text" value="4.612000"/>	Events	
<input type="checkbox"/> Wavelength			<input type="checkbox"/> Wavelength			Required	Actual
<input type="checkbox"/> Waveform			<input type="checkbox"/> Waveform			<input type="text" value="1000"/>	<input type="text" value="1000"/>
<input type="checkbox"/> Histogram			<input type="checkbox"/> Histogram			<input type="button" value="Update"/>	
<input type="checkbox"/> History			<input type="checkbox"/> History				
<input type="checkbox"/> Setting			<input type="checkbox"/> Setting				

## Laser Settings

## Waveform Display

**Setting1 Disp**

YLF Laser	Ti:S Laser	DG535	Monitor
Shutter	Shutter	Trigger	Mode
<input type="button" value="CLOSE"/>	<input type="button" value="CLOSE"/>	<input type="button" value="Internal"/>	<input type="button" value="SCAN"/> <input type="button" value="↓"/>
Lamp	Wavelength	Rep. Rate	Channel
<input type="button" value="OFF"/>	<input type="text" value="440 nm"/>	<input type="text" value="100"/>	<input type="text" value="1"/>
Current	Energy	Delay A	Events
<input type="text" value="15.00"/>	<input type="text" value="0"/>	<input type="text" value="2.679500"/>	<input type="text" value="1000"/>
Cooler	Temperature	Delay B	Gate (ns)
<input type="button" value="OFF"/>	<input type="text" value="20.00"/>	<input type="text" value="4.612000"/>	<input type="text" value="200"/>
		Delay C	
		<input type="text" value="0.000000"/>	
		Delay D	
		<input type="text" value="0.000000"/>	

**Wave1 Disp**

YLF Laser	Ti:S Laser
Energy (mJ)	Energy (mJ)
<input type="text" value="1.437e+01"/>	<input type="text" value="9.084e-01"/>
FWHM (ns)	FWHM (ns)
<input type="text" value="1.395e+02"/>	<input type="text" value="2.167e+01"/>
Half (ns)	Half (ns)
<input type="text" value="2.238e+02"/>	<input type="text" value="4.794e+02"/>
Center (ns)	Center (ns)
<input type="text" value="3.342e+02"/>	<input type="text" value="4.939e+02"/>

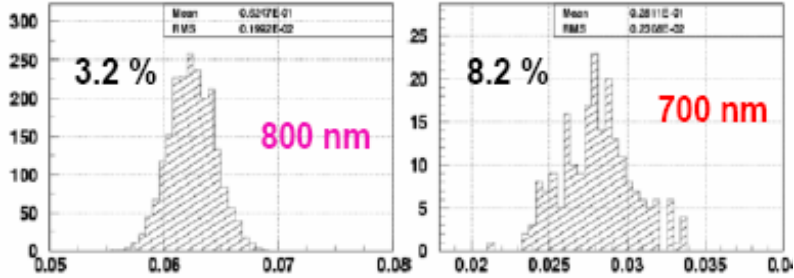
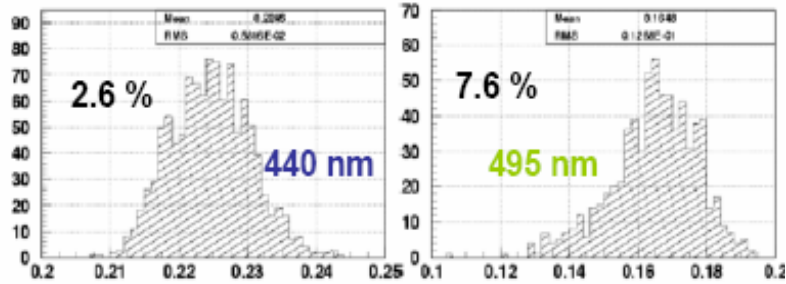




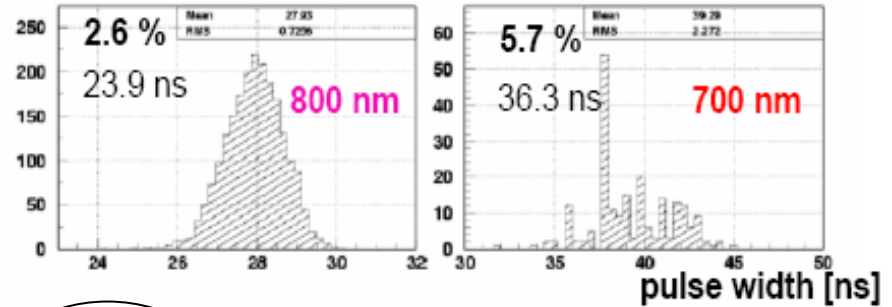
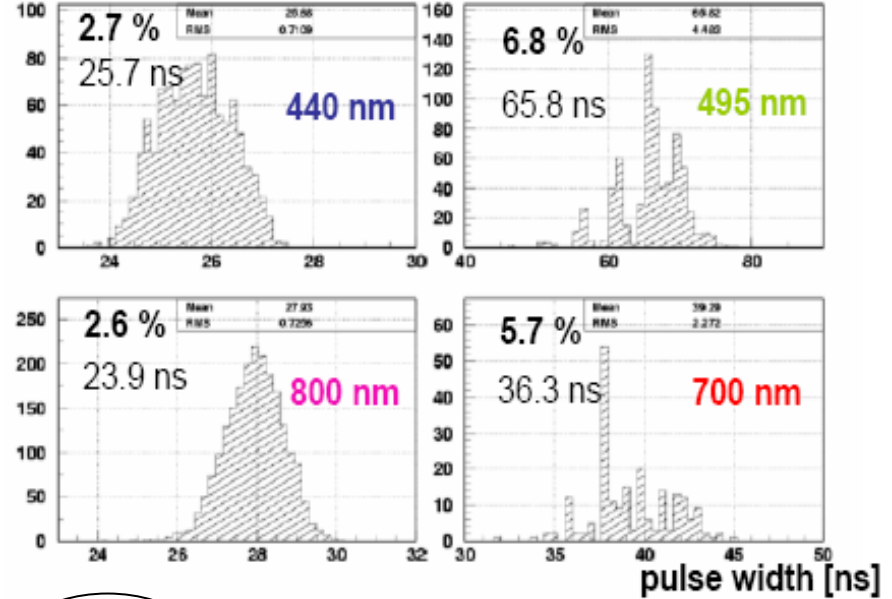
# Result of the Slow Monitor: Intensity, FWHM, Timing



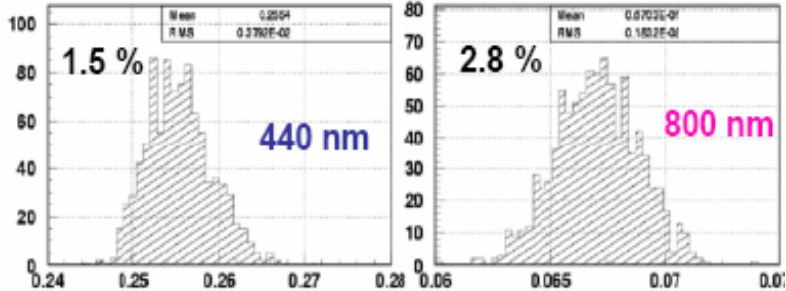
$t_{ref} : 330 - 355 \text{ h}$



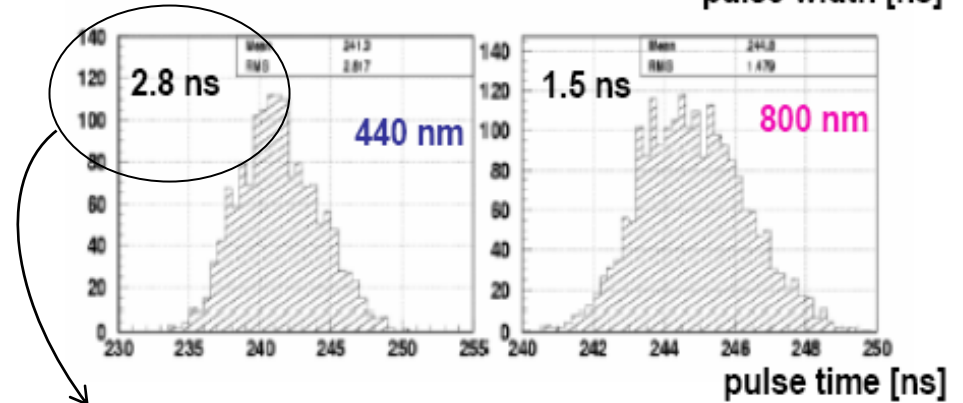
$t_{ref} : 330 - 355 \text{ h}$



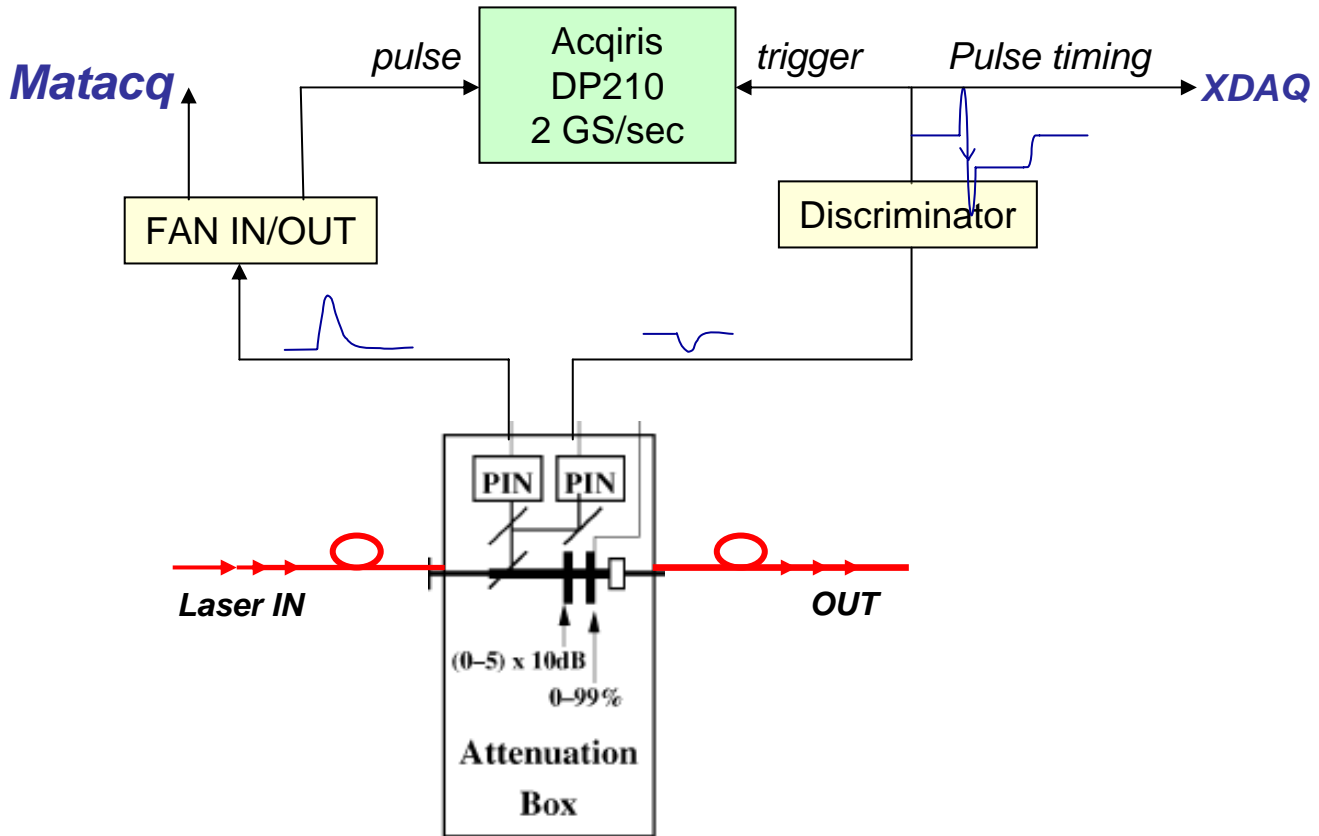
$t_{ref} : 200 - 200.5 \text{ h}$



Pulse energy



Pulse jitter of monitoring light



MATAcq: Fast acquisition card developed by *CEA/Saclay, IN2P3/LAL*  
 Sample frequency: 1GHz, 2GHz in boosted mode.

# Acqiris DP210 Card (2GS/s, 2004)

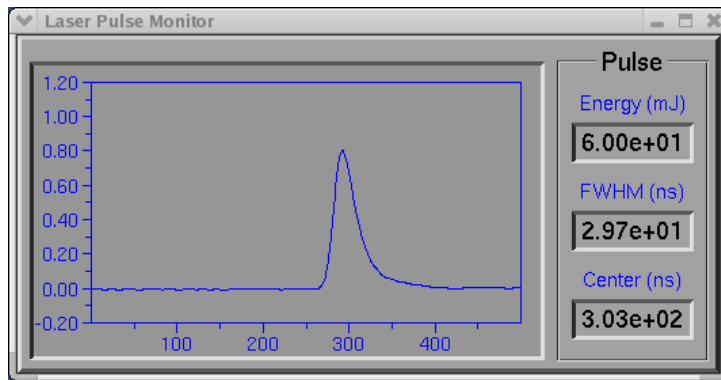
To follow Ti:S performance pulse by pulse



Fast sampling ADC (2 GS/s) on one PC  
 → Acqiris DP210, PCI card with oscilloscope characteristics, 500MHz BW, 8bit



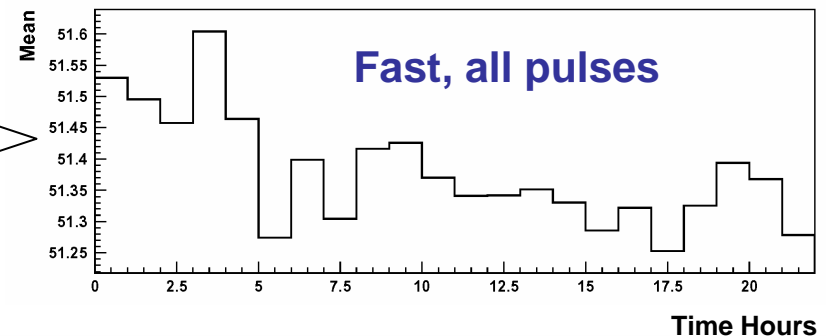
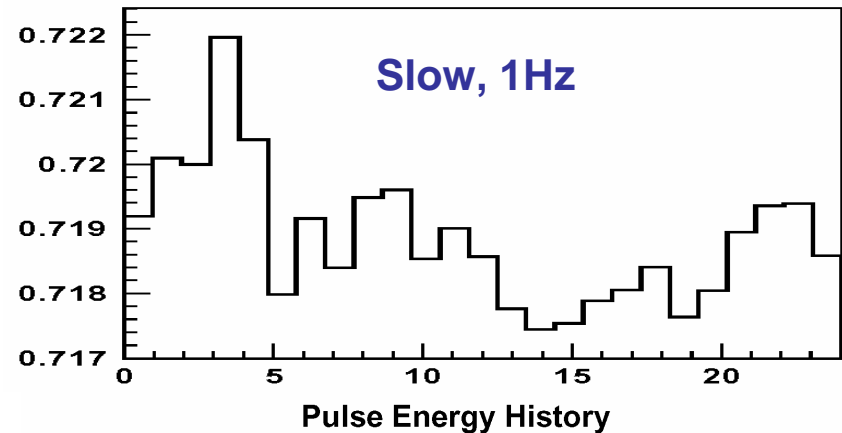
Record all Ti:S pulses: Intensity & FWHM  
 No laser timing information: self-triggered



Option: filter 60MHz available



440 nm,  
Same run







# Communication with ECAL: Laser Supervisor



Communication with the XDAQ is through Ethernet.

At the beginning of each run, the DAQ sets and checks laser parameters by sending a command file, and the laser responds to the DAQ by sending an acknowledge file.

## Laser parameters controlled by XDAQ :

- laser wavelength (*change : ~1 min.*),
- linear attenuator,
- output channel number of the 1x80 optical switch.



# Communication Protocol



1. The command file from the **H4 DAQ** to the laser:
  - COMMAND TYPE** (int) 0: request laser parameters  
1: set laser parameters  
2: get laser parameters and pulse information
  - WAVELENGTH** (int) 0: 440 nm  
1: 495 nm  
2: 709 nm  
3: 800 nm
  - ATTENUATOR** (int) 1 – 99 % of laser power, in 1% step
  - SWITCH CHANNEL** (int) 1 – 80
  - CHECK-SUM** (int) Bitwise inversion of the sum of preceding 4 data
2. The acknowledge file from the laser to the **DAQ**:
  - COMMAND TYPE** (int) 0: setting in progress  
1: setting finished, the laser parameters are ready
  - WAVELENGTH** (int) 0: 440 nm  
1: 495 nm  
2: 709 nm  
3: 800 nm
  - ATTENUATOR** (int) 1 – 99 % of laser power, in 1% step
  - SWITCH CHANNEL** (int) 1 – 80
  - CHECK-SUM** (int) Bitwise inversion of the sum of preceding 4 data

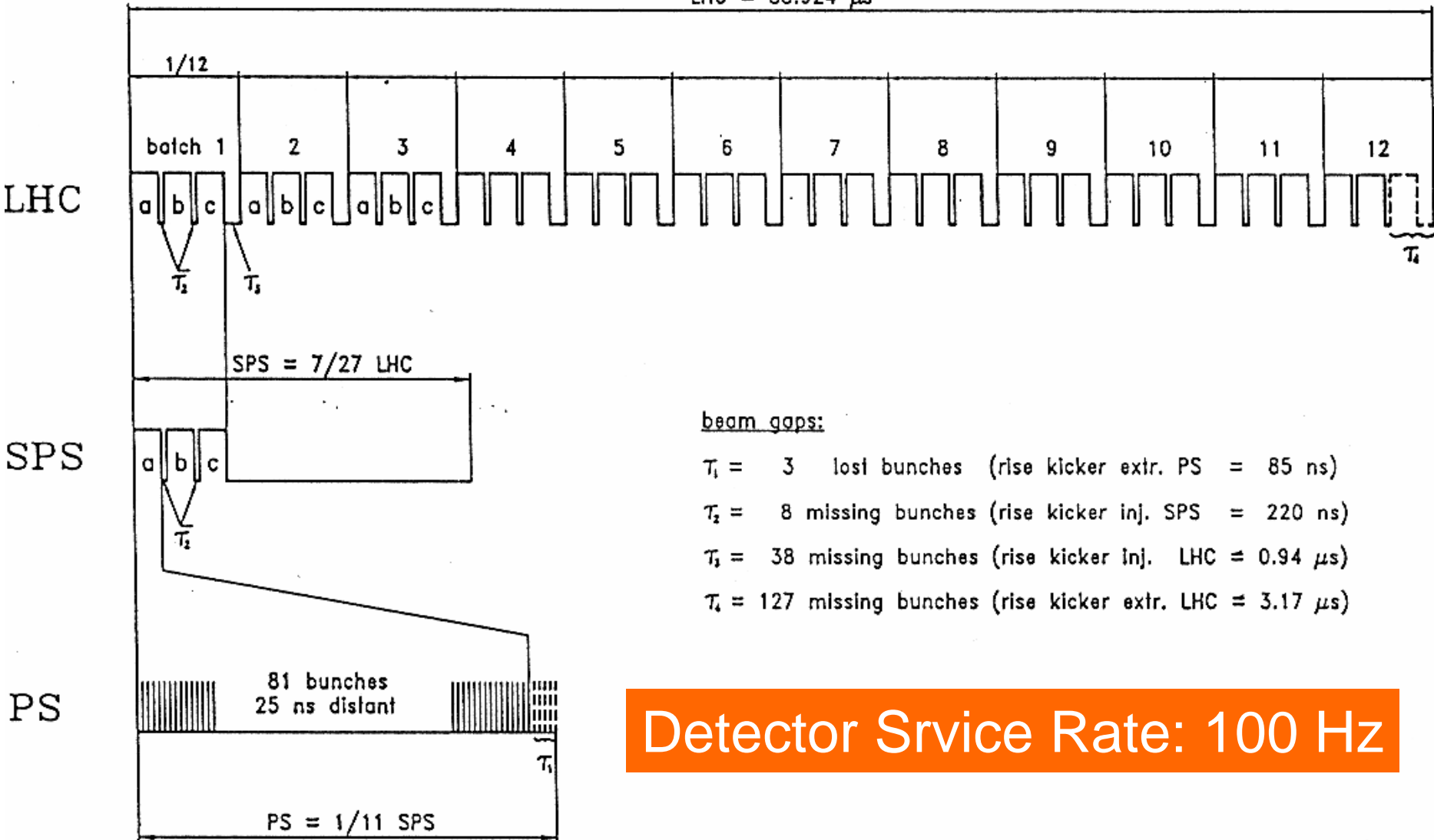


# Continuous Monitoring at CMS



Using 1% beam gaps in the LHC beam structure

LHC = 88.924  $\mu$ s



Detector Service Rate: 100 Hz





# Time Needed to Scan the ECAL



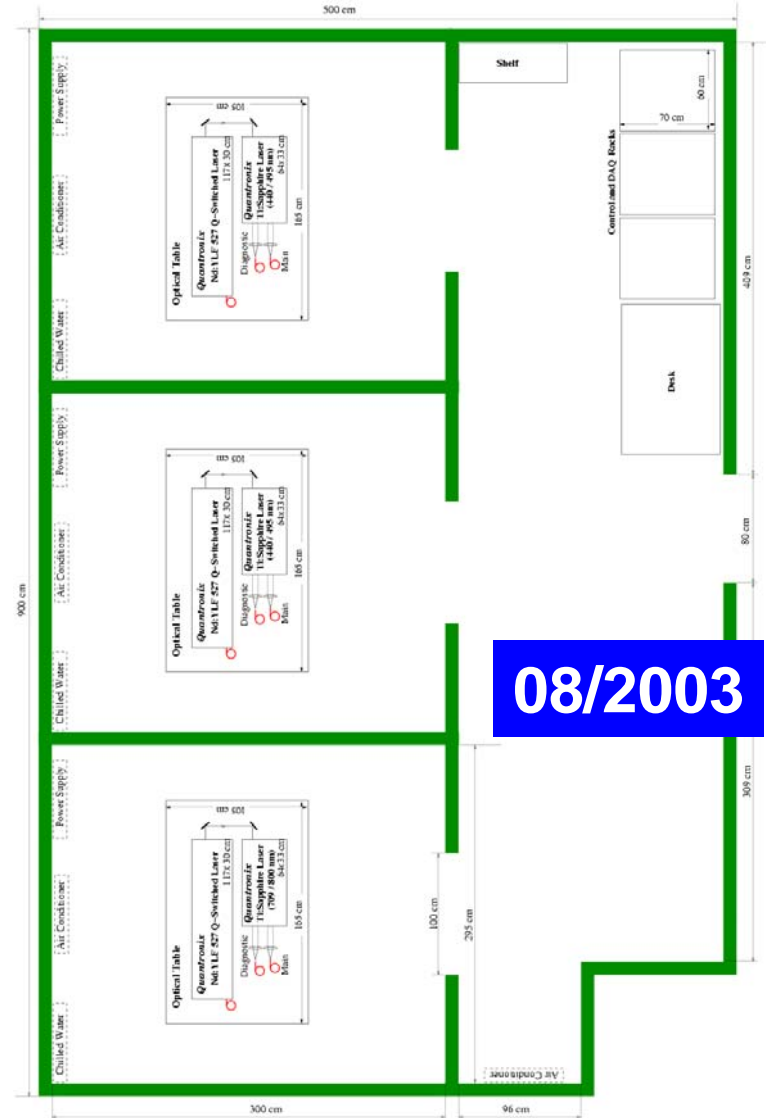
Time to scan entire ECA: **30 min (23 sec/channel)**

Time needed for channel switching:

With laser DAQ control:	1 sec/Channel
With client communication:	2 sec/Channel
With slow monitor data taking:	4 sec/Channel

- The total time depends on # of events/channel & XDAQ overhead
- Laser scan may also be controlled by the laser DAQ, not the XDAQ
- **If so, can the XDAQ handle the laser scan data?**

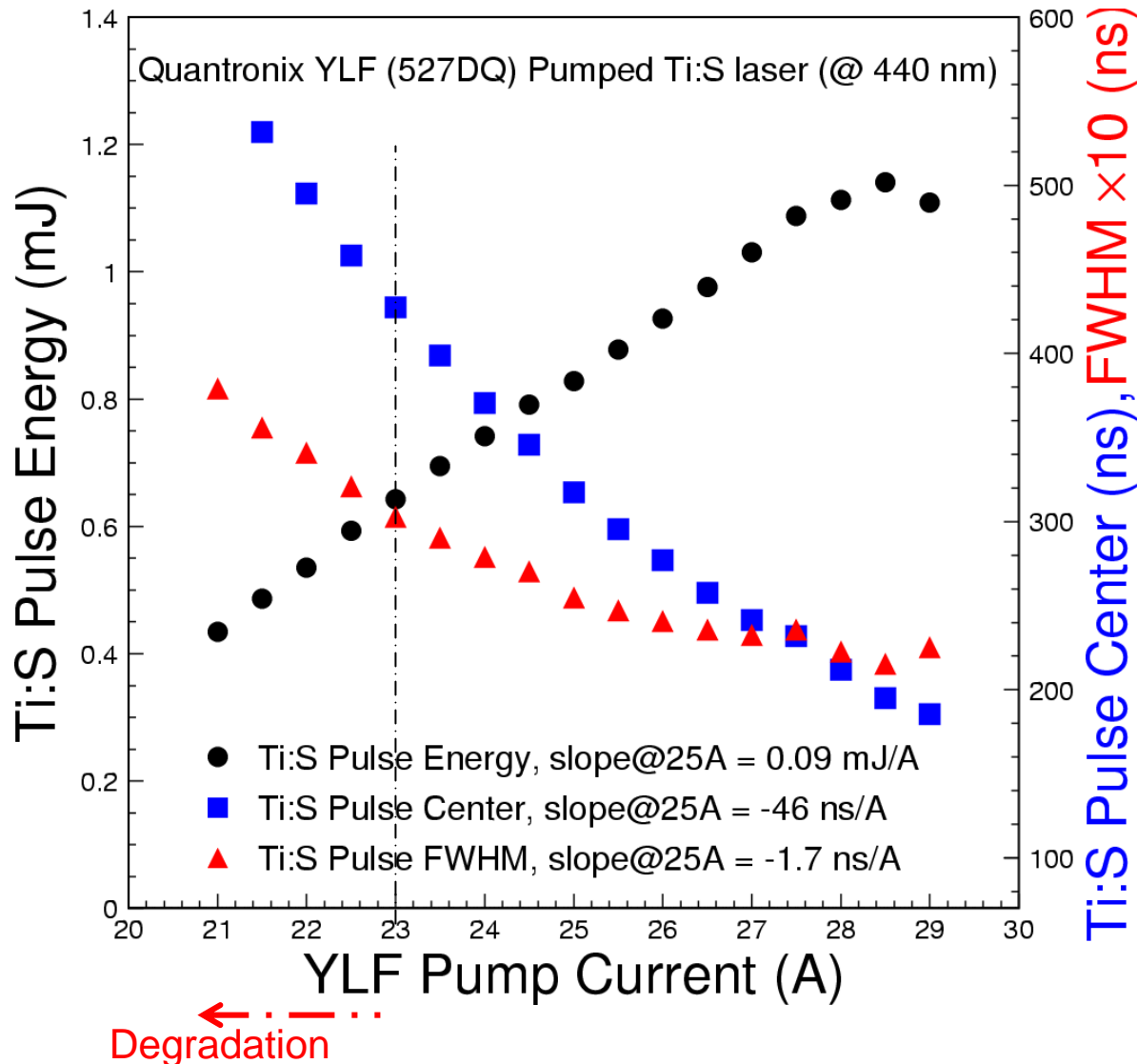
# Monitoring Laser Barracks at H4





Portable softwall clean room facilities installed in the H4 laser barracks at CERN in Spring, 2005. They provide an environment of better than class 1,000 for laser optics protection (measured at 100)

Laser short/long term stabilities:  $< 2\%$  and  $3\%$ ; lamp aging:  $0.5\%$  daily. A stable laser pulse would improve monitoring stability.

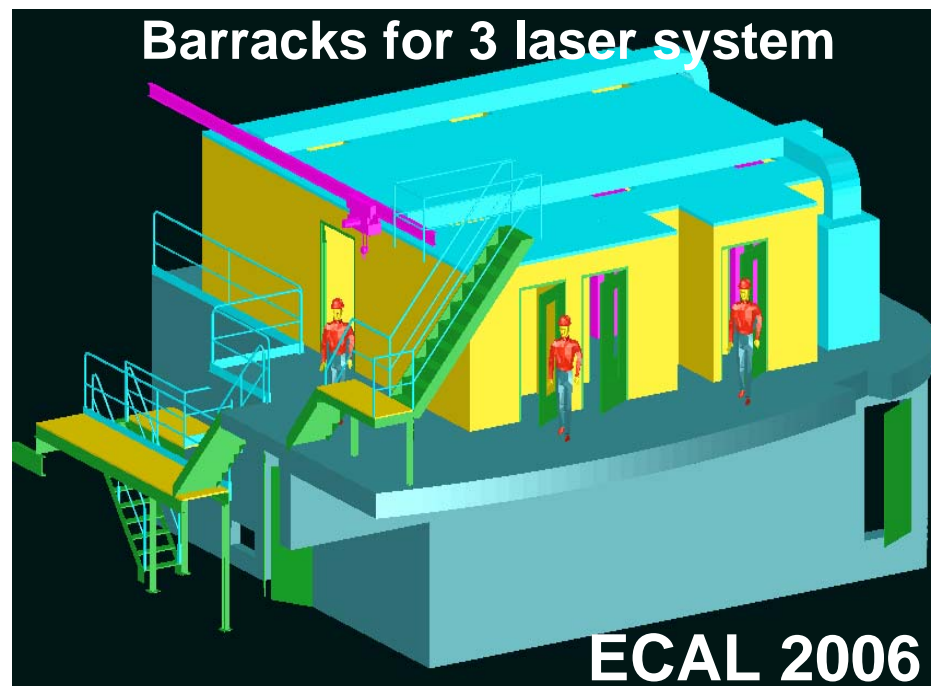
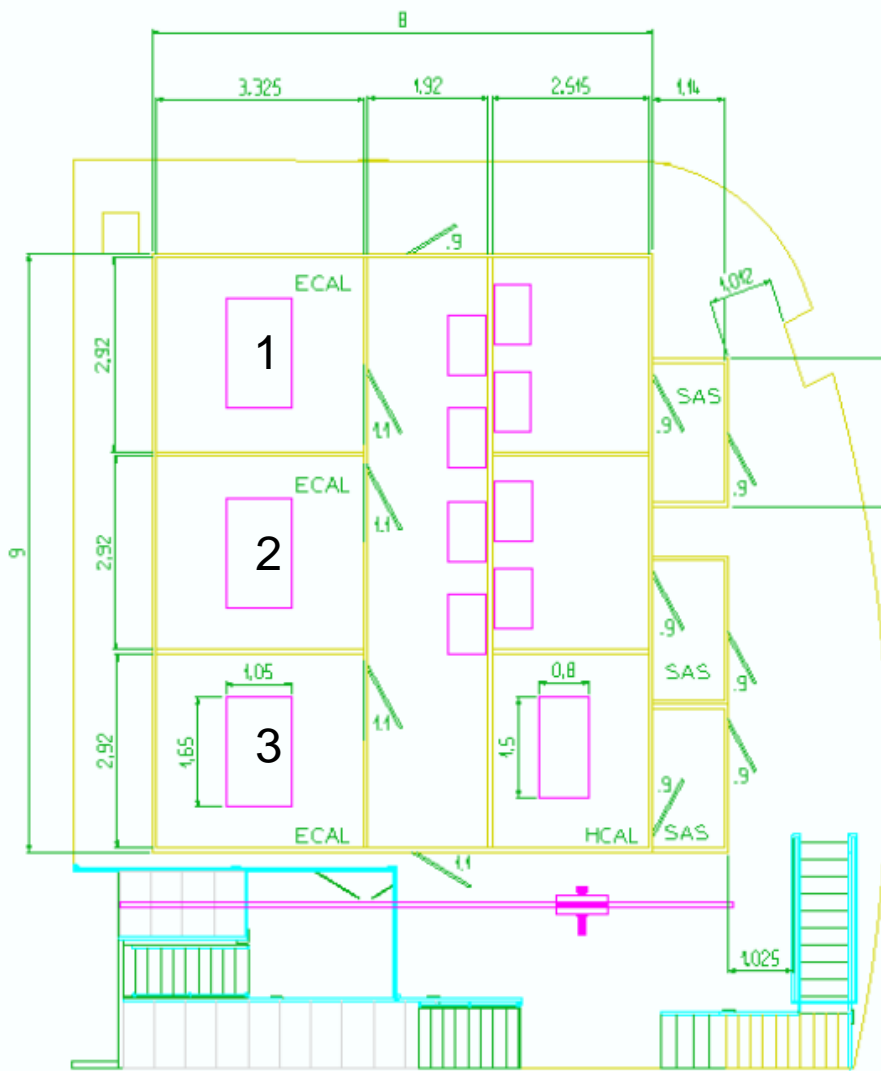


Laser pulse intensity, width and timing are correlated with the pumping current.

Better pulse stability could be achieved by trimming the YLF pumping current.

Dr. Kejun Zhu wrote a code, which will be tested by Dr. Liyuan Zhang during his visit at CERN on September 24-28, 2005





Barrack ready for April 2006

**New: temperature stability  $\pm 0.5$  °C**

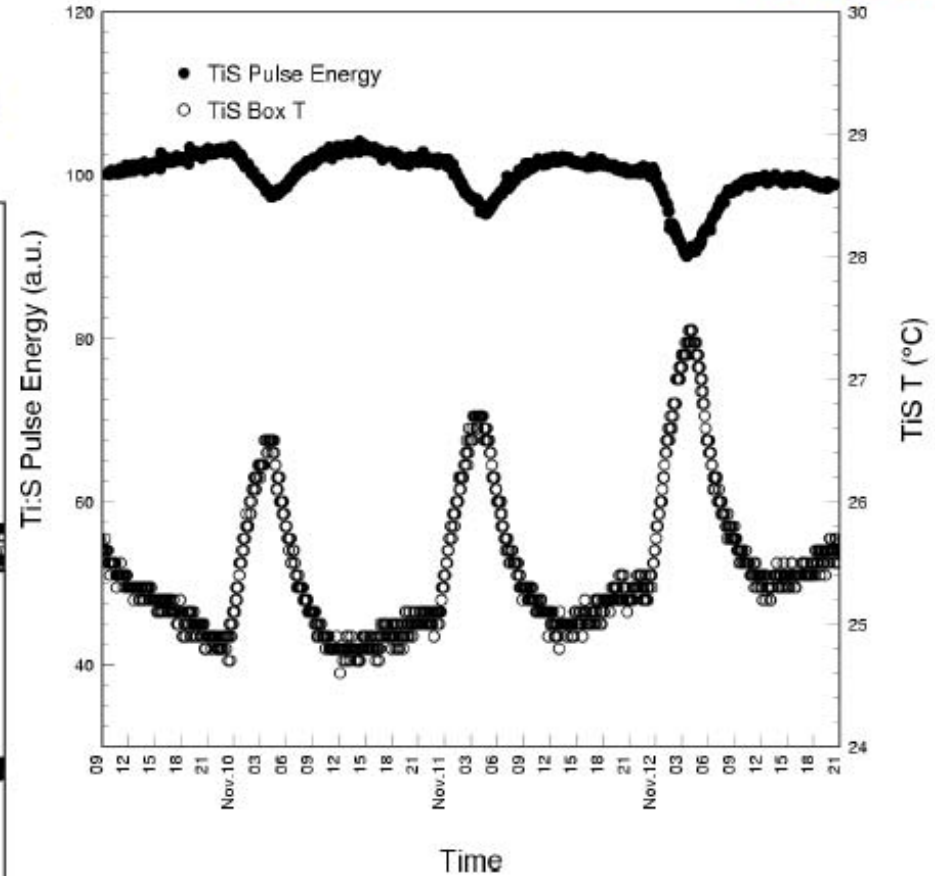
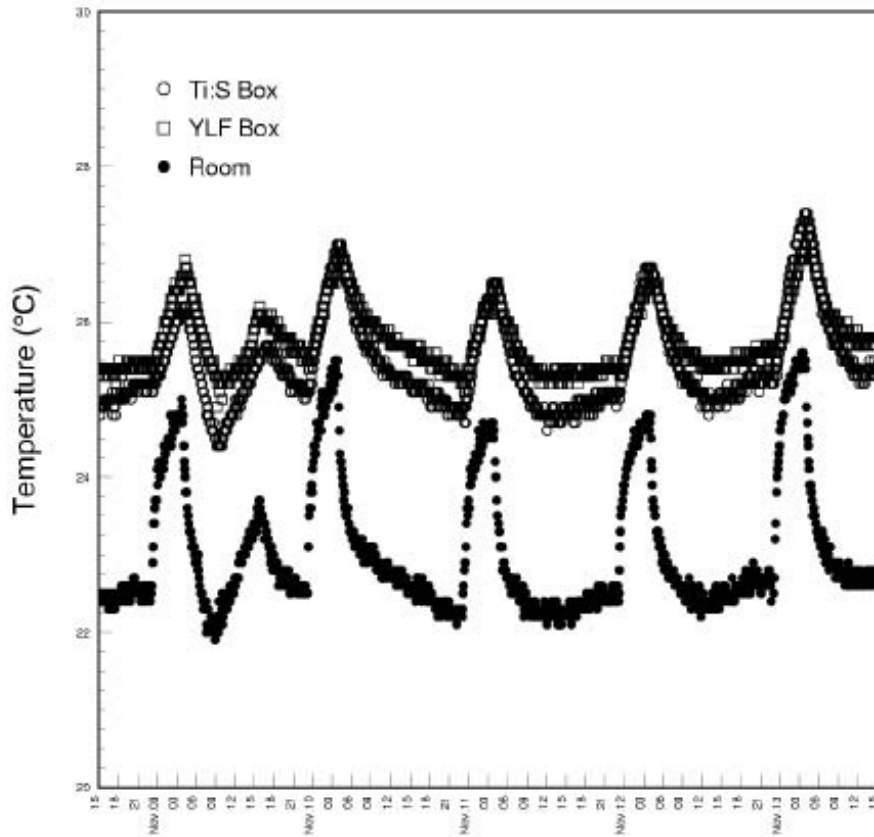
One laser will be moved to USC55 in 2006?



# A Study on Temperature Effect

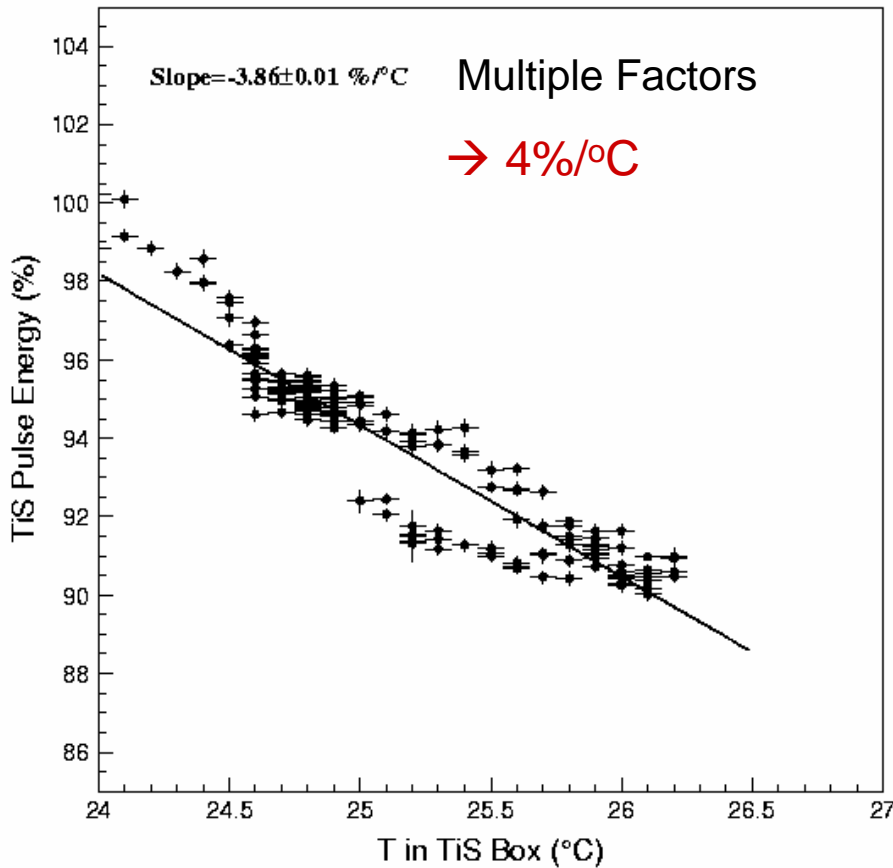


## Room T Variations in 5 Days



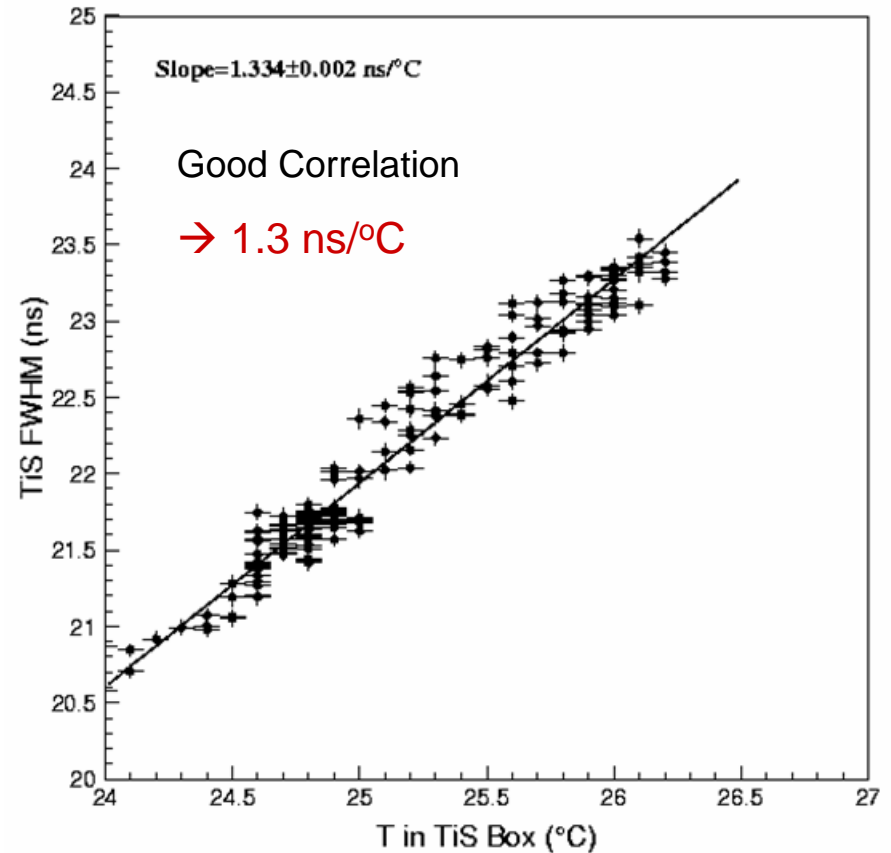
## Ti:S Pulse Energy and T

# Temperature Dependence



Ti:S Pulse Energy versus T

## Ti:S Pulse FWHM versus T





# Conclusion



Laser performance :

- Pulse width: OK
- ⇒ - Pulse jitter: 3 ns (24 h)
- Short term (0.5 h) instabilities: <2%
- Long term (24 h) instability: 3%



*Stability getting  
better with  
improved  
environment*

→ All 3 monitoring systems are consistent

⇒ Laser maintenance: every **40 days minimum**

In H4: put spare laser online each time? else stop data taking?

CMS: need a 1x3 optical switch to reduce the transition time

- ⇒ To do list:
- Software feedback will be tested on September 24-28, 2005
  - Develop scan software if ECAL scan is controlled by the laser DAQ
  - Procure a 1x3 switch and a 1x80 switch as spare (*broken in July, 05*)
  - Laser at USC55: installation schedule to be defined

Decisions on (1) when the laser system is needed at USC55 and (2) if we want to keep two working laser systems at both H4 and USC55 and for how long are important for our planning.